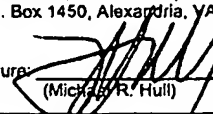


I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: MS Final, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: June 28, 2005      Signature:  (Michael R. Hull)

AF  
ITW

Docket No.: 29926/39504  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Ju-Il Lee

Application No.: 10/669,996

Confirmation No.: 6198

Filed: September 24, 2003

Art Unit: 2813

For: METHOD FOR MANUFACTURING CMOS  
IMAGE SENSOR USING SPACER ETCHING  
BARRIER FILM

Examiner: Monica D. Harrison

**AMENDMENT AFTER FINAL (37 C.F.R. §1.116)**

MS Final  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Amendment  
entered  
MDH  
7/19/05

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the final office action dated April 28, 2005, please amend the above-identified U.S. patent application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.